

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

December 9, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG755528231

LABORATORY GROWN DIAMOND

MARQUISE BRILLIANT

13.08 X 6.59 X 4.11 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

2.02 CARATS

F

VVS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

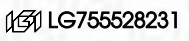
EXCELLENT

EXCELLENT

NONE

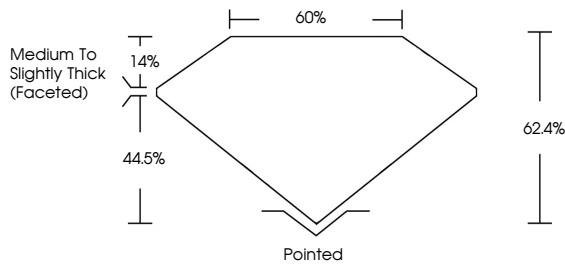
Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

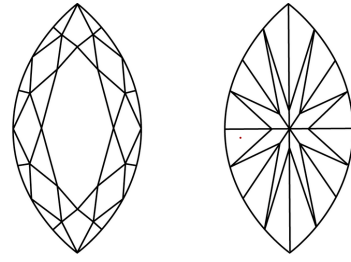


IGI LG755528231

PROPORTIONS



CLARITY CHARACTERISTICS




KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

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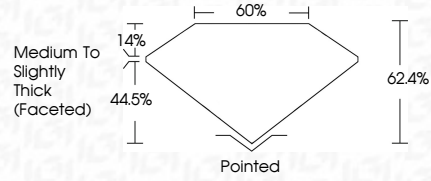
EXCELLENT

NONE

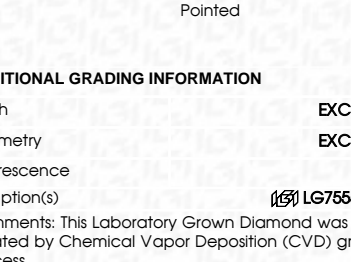
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IGI





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MARQUISE BRILLIANT

13.08 X 6.59 X 4.11 MM

2.02 CARATS

F

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

VVS 1

62.4%

65%

Medium to Slightly Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

IGI LG755528231

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

None

Excellent

Excellent

None

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